



B

Patent  
Attorney's Docket No. 015290-504

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	
	)	
Tuqiang NI et al.	)	Allowed: September 30, 2003
	)	
Application No.: 09/883,207	)	Confirmation No.: 9862
	)	
Filed: June 19, 2001	)	Group Art Unit: 1765
	)	
For: PLASMA ETCHING OF DIELECTRIC	)	Examiner: D. V. Deo
LAYER WITH ETCH PROFILE	)	
CONTROL	)	
	)	

**REQUEST FOR CORRECTED NOTICE OF ALLOWABILITY**

**MAIL STOP: ISSUE FEE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

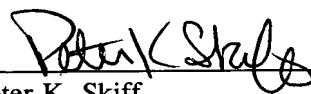
Sir:

Enclosed please find a copy of the Notice of Allowability dated September 30, 2003 received by the undersigned wherein Box 4 incorrectly acknowledges a claim for foreign priority. The above-identified application does not claim foreign priority. Accordingly, a Supplemental Notice of Allowability is requested removing the "X" from Box 4, 4(a) and 4(a)(1).

Respectfully submitted,

BURNS, DOANE, SWECKER & MATHIS, L.L.P.

Date: October 3, 2003

By:   
Peter K. Skiff  
Registration No. 31,917

P.O. Box 1404  
Alexandria, Virginia 22313-1404  
(703) 836-6620

(05/03)